

Physikalisch-Technische Bundesanstalt **Braunschweig und Berlin** National Metrology Institute

Characterization of artificial and aerosol nanoparticles with aerometproject.com reference-free grazing incidence X-ray fluorescence analysis

Philipp Hönicke, Yves Kayser, Rainer Unterumsberger, Beatrix Pollakowski-Herrmann, Christian Seim, Burkhard Beckhoff Physikalisch-Technische Bundesanstalt (PTB), Abbestr. 2-12, 10587 Berlin

Introduction

In most cases, bulk-type or micro-scaled reference-materials do not provide optimal calibration schemes for analyzing nanomaterials as e.g. surface and interface contributions may differ from bulk, spatial inhomogeneities may exist at the nanoscale or the response of the analytical method may not be linear over the large dynamic range when going from bulk to the nanoscale. Thus, we have a situation where the availability of suited nanoscale reference materials is drastically lower than the current demand.

Reference-free XRF

Reference-free X-ray fluorescence (XRF), being based on radiometrically calibrated instrumentation, enables an SI traceable quantitative

Characterization of nanoparticle depositions

Reference-free GIXRF is also suitable for both a chemical and a dimensional characterization of nanoparticle depositions on flat substrates. By means of the reference-free quantification, an access to deposition densities and other dimensional quantitative measureands is possible.

By employing also X-ray absorption spectroscopy (XAFS), also a chemical speciation of the nanoparticles or a compound within can be performed.

Nominal 30 nm ZnTiO3 particles: Ti and Zn GIXRF reveals homogeneous particles, Chemical speciation XAFS



AEROME



characterization of nanomaterials without the need for any reference material or calibration specimen. This opens a route for the XRF based qualification of calibration samples.

Sherman equation for K fluorescence



J. Anal. At. Spectrom. (2008) 23, 845 - 853

Experimental capabilities

• TXRF, GIXRF and XRF • NEXAFS / XANES • EXAFS • XRR

Accessible photon energy range: 80 eV – 1875 eV @ PGM beamline 1.740 keV – 10.5 keV @ FCM beamline 6.5 keV – 80 keV @ BAMline



monochromatic excitation radiation sample Y sample Z





Reference-free GIXRF quantification of Pt-TiO₂ core-shell nanoparticle depositions with different deposition densities.

GIXRF measurement

nominal surface coverage --- 5.0 %

..... 30 %





Characterization of artificial 2D nanostructures

10 incident angle / °



In a second example, we work on the development of nanostructures as calibration samples. Several lithographic 2D grating structures have been fabricated and characterized using the reference-free GIXRF methodology of PTB. Here, an advanced calculation scheme based on the finite element method for the intensity distributions within the X-ray standing wave field (XSW) is required. In addition to the traceable quantification of elemental mass depositions, this allows for a determination of in-depth elemental distributions and the dimensional properties of the nanostructures.



incident angle /

·130%



STEM Image

Reference-free XRF in grazing incidence geometry





Grazing incidence XRF is based on a variation of the incident angle of the exciting radiation. Due to the interference between incident and reflected beam an X-ray standing wave field (XSW) arises and strongly modifies the local intensity. By scanning the angle, the depth dependent changes of the XSW can be used as a nanoscaled depth sensor in order to gain dimensional information about the sample. In conjunction with the reference-free setup, this can be Principle of GIXRF used to reveal quantitative information about different types of



reference-free GIXRF

Materials (2014) **7(4)**, 3147-3159

SEM images of the characterized Si₃N₄ grating structure



FEM calculated data

5 nm shell

9 nm shell

1.5 2.0 2.5 3.0

Nanoscale (2018) 10, 6177-6185

Characterization of 3D artifical particle-like nanostructures

In principle, the methodology is also well suited to characterize 3D nanostructures for calibration sample applications. Here, electron beam lithography was used to fabricate regular and irregular ordered chromium pads with nominal sizes of 300 x 300 x 20 nm³. They were also characterized using the reference-free GIXRF methodology of PTB.

Here, the experimental data from the irregular sample is modeled using the effective density approach. The nanostructures are approximated as a layer of Cr with reduced density. The density can be calculated as a function of the dimensional parameters of the structures.

The regular structures also show a strong dependence on the azimuthal angle. However, they cannot be modeled using the effective density approach requiring also the FEM based technique. As

this results in a much larger computational effort as compared to 5 the 2D gratings, it could not be performed so far. Due to the high amount of features in the data, we expect a high sensitivity for both the dimensional parameters and the elemental distributions.

Schematic view of nano-squares





Comparison of an experimental GIXRF curve for irregularly and regularly ordered chromium nanoblocks (see insets). For the irregular blocks also a calculated GIXRF

signal assuming ideally shaped rectangles is shown.



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Dr. Philipp Hönicke 7.24 X-ray Spectrometry Abbestr. 2-12 10587 Berlin, Germany Telefon: +49 (0)30 3481 7174 +49 (0)30 3481 69 7174 Fax: Email: philipp.hoenicke@ptb.de www.ptb.de

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